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APPLICANTS

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** CONTINUING DATA ***** *none y/H*

** FOREIGN APPLICATIONS ***** *yes y/H*
 JAPAN 2002-325383 11/08/2002

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>Examiner's Signature</i> <i>8/2/05</i> <i>Initials</i>	STATE OR COUNTRY JAPAN	SHEETS DRAWING 11	TOTAL CLAIMS 30	INDEPENDENT CLAIMS 10
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TITLE
 Laser irradiation apparatus and method of fabricating semiconductor device

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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